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Docket No.: 8733.477.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yong-Il Doh

Confirmation No.: 1523

Application No.: 10/021,013

Art Unit: 1763

Filed: December 19, 2001

Examiner: S. MacArthur

For: ETCHING APPARATUS OF GLASS  
SUBSTRATE

Customer No.: 30827

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated April 30, 2004 (Paper No. 2), please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.